

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KOBAYASHI, *et al.*

Serial No.: 10/585,994

Filed: July 13, 2006

For: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE AND FILM DEPOSITION SYSTEM

Confirmation No. 8859

Art Unit: 2823

Examiner: Kevin A. PARENDO

Atty. Docket: 033082M336

PETITION FOR A THREE-MONTH EXTENSION OF TIME

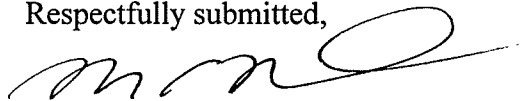
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for an Extension of Time for a 3 month period. This Petition for Extension of Time is being concurrently filed with a Response.

Payment of the requisite fee is being made online with a credit card using EFS-Web.

Respectfully submitted,



Michael A. Makuch
Registration No. 32,263

Date: April 7, 2010
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